



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

III THE STATES OF THE STATES O		
In re application of:	Art Unit: Not assigned	
Michihiro MIZUNO	Examiner: Not assigned	
Serial No: Not assigned		
Filed: September 25, 2001		
For: METHOD FOR EVALUATING CONCENTRA' METAL IMPURITIES IN SILICON WAFER	ION OF	
CERTIFICATE OF MAILING "Express Mail" Mailing Labe Date of Deposit: Se	l No. <u>EL 894 944 374 US</u>	
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Dear Sir:		
 ∠ sheet(s) of formal drawings ∠ executed Declaration and Power of Atto ∠ assignment of the invention to SHIN-E ∠ Information Disclosure Statement with _ ∠ return postcard 	cification <u>; 18</u> claim(s); <u>1</u> page(s) of ney <u>TSU HANDOTAI CO., LTD.</u> 2_ references	
are being deposited with the United States Postal service with sufficient postage under 37 C.F.R. § 1.10	Service "Express Mail Post Office to A on the date indicated above and are addr	.ddressee" essed to:
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Los Angeles, California 90071 Telephone: 213-337-6700

Facsimile: 213-337-6701